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BY EXPRESS MAIL ON
October 26, 2001
(EK 825 216 565 US)

10/26/01
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Box PATENT APPLICATION
ASSISTANT COMMISSIONER FOR PATENTS
Washington, DC 20231

RECORD OF TRANSMITTAL

INVENTORS: (1) Takashi KAITO

TITLE: BEAM SHAPED FILM PATTERN FORMATION METHOD

DOCKET NO: S004-4433

S I R:

Kindly find enclosed herewith for filing the documents checked below. Any fees or charges not covered by the accompanying check should be charged to our Deposit Account No. 01-0268.

APPLICABLE ITEMS CHECKED:

- XX PATENT APPLICATION (pages 1-8 of specification, 6 claims (page) 8 and abstract of the disclosure (page 9))
- DESIGN APPLICATION (specification, claim, declaration and power of attorney and photograph(s))
- XX FORMAL DRAWINGS (5 sheets) (NI A4)
- INFORMAL DRAWINGS (sheets)
- RECORDATION FORM COVER SHEET and ASSIGNMENT (to be recorded and returned to the undersigned)

100433302601

XX PRIORITY CLAIM - applicant(s) claim the benefit of
priority of the following application(s):

Japanese Patent Appln. No. 2000-333368 filed Oct. 31, 2000

XX PRIORITY DOCUMENT(s)

 Enclosed XX Not Enclosed

 VERIFIED STATEMENT TO ESTABLISH SMALL ENTITY STATUS

XX EXPRESS MAIL CERTIFICATION

 OTHER -

XX FEE

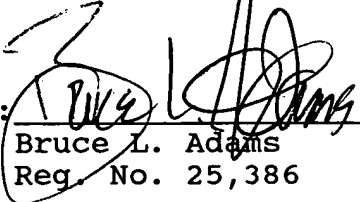
A check is enclosed for the following official fees:

	Large Entity	Small Entity
<u>XX</u> Basic Filing Fee	\$ 740.00	\$
<u> 0 </u> Independent Claims in Excess of 3	\$	\$
<u> 0 </u> Total Claims in Excess of 20	\$	\$
<u> </u> Multiple Claim Fee	\$	\$
<u> </u> Assignment Recordal Fee	\$	\$
TOTAL	\$ 740.00	\$

Respectfully submitted,

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By: 
Bruce L. Adams
Reg. No. 25,386

Re: New patent application of Takashi KAITO
for BEAM SHAPED FILM PATTERN FORMATION METHOD

comprising transmittal letter, title, specification (pgs.1-8),
6 claims (pg.8), abstract of the disclosure (pg.9), 5 sheets of
formal drawings containing thereon Figs. 1A-5, express mail
certification and check in the amount \$740.00

Attorney's Docket No: S004-4433

EXPRESS MAIL CERTIFICATION UNDER 37 CFR §1.10

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Michael Ruas

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